



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re Application of:**

Hikaru YOSHITAKA

Application No.: 09/658,861

Group Art Unit: 2812

Filed: September 8, 2000

Examiner: Nguyen, H.

For: ~~SEMICONDUCTOR DEVICE AND~~  
METHOD OF MANUFACTURING  
THE SAME

Commissioner for Patents  
Washington, DC 20231

Sir:

## PETITION FOR EXTENSION OF TIME

Applicant hereby petitions for a three month extension of time to reply to the Office Action of May 9, 2002. A fee of \$920.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

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Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: November 12, 2002

By

Brett C. Martin  
Reg. No. 52,000

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